



Patent Attorney  
Docket No. 81329A

2877  
3

TRANSMITTAL LETTER

Inventor: Joseph J. Danko  
Serial No: 09/579,593  
Filing Date: 5-26-00  
Notice of Allowance:

Group Art Unit: 2877  
Examiner: Unknown  
Batch:

For: METHOD AND APPARATUS FOR INSPECTING A PATTERNED SEMICONDUCTOR WAFER

Assistant Commissioner for Patents  
Washington, D. C. 20231

Dear Sir:

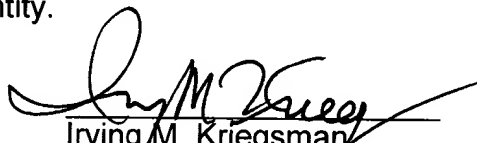
Transmitted herewith for the above-identified patent application are the following:

An Information Disclosure Statement  
Form PTO-FB-A820 (1 sheet)  
Copies of 8 documents  
A return postcard

The item(s) checked below are appropriate:

- an 1.     Applicant(s) hereby petition(s) for a ( ) month extension of time to respond to  
dated .
2. X Please charge any fees or costs not accounted for to Deposit Account No. 11-  
1755.
3.     Applicant is a small entity.

Date: May 30, 2001

  
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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Assistant Commissioner for Patents, Washington, D. C. 20231 on 5-30-01.

  
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